

EXPRESS MAIL No.: EV 304 055 728 US

Deposited: January 30, 2004

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Date: 01/30/04

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No. JG-SU-5196 / 500577.20055

Applicant(s): Kazuhiro HARADA, Yoji SUZUKI and Hidenobu ABE

Application No.:

Filed: concurrently herewith –January 30, 2004

For: METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL AND SILICON SINGLE CRYSTAL MANUFACTURED BY THE METHOD

BOX Patent Application
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

The above-identified application is filed concurrently herewith, please amend the specification and claims as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims, which begin on page 3 of this paper.

Remarks / Arguments begin on page 9 of this paper.